

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Case No. 07-1233-US)**

In the Application of:	)	
	)	
<b>Terry L. Alford, et al.</b>	)	
	)	Examiner: <b>Stanetta D. Isaac</b>
Serial No.: <b>10/579,051</b>	)	
	)	Group Art Unit: <b>2812</b>
Filing Date: <b>May 9, 2006</b>	)	
	)	Confirmation No.: <b>6367</b>
For: <b>Flexible Electronics Using Ion Implantation</b>	)	
<b>to Adhere Polymer Substrate to Single</b>	)	
<b>Crystal Silicon Substrate</b>	)	

BOX: Response  
 Commissioner for Patents  
 PO Box 1450  
 Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION, MAILED APRIL 3, 2008**

Dear Sir,

Please consider the following amendments and remarks in response to the Office Action mailed April 3, 2008. Applicants respectfully request that the following amendment be entered in the above-mentioned application.

**Amendments to Claims** begin on page 2 of this paper

**Remarks** begin on page 6 of this paper